Jeong-Min CHOI et al.
SEMICONDUCTOR DEVICE HAVING SILICIDE LAYERS AND METHOD OF FABRICATING THE SAME
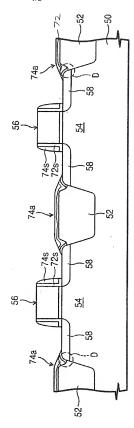Attorney Docket No. 4591-366/Application No. 10/750,983

Annotated Sheet Showing Changes

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Fig. 8

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Annotated Sheet Showing Changes

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Fig. 11